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APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/604,636	C	08/06/2003	Kyra Moellmann	LASP:129US	LASP:129US 1635	
24041	7590	12/27/2005		EXAMINER		
		SON, PLLC	WILLIAMS, DON J			
5555 MAIN STREET WILLIAMSVILLE, NY 14221-5406				ART UNIT	PAPER NUMBER	
				2878	2878	
			DATE MAILED: 12/27/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	
		10/604,636	MOELLMANN, KYRA	
	Office Action Summary	Examiner	Art Unit	- (\)
		Don Williams	2878	
Period fo	The MAILING DATE of this communication app	pears on the cover sheet with the c	orrespondence addre)ss
A SH WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DA asions of time may be available under the provisions of 37 CFR 1.1: SIX (6) MONTHS from the mailing date of this communication. period for reply is specified above, the maximum statutory period v re to reply within the set or extended period for reply will, by statute eply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	N. nely filed the mailing date of this comm D (35 U.S.C. § 133).	
Status				
2a)□	Responsive to communication(s) filed on <u>06 Al</u> This action is FINAL . 2b) This Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. nce except for formal matters, pro		erits is
Dispositi	on of Claims			
5)□ 6)⊠ 7)□	Claim(s) 1-15 is/are pending in the application. 4a) Of the above claim(s) is/are withdraw Claim(s) is/are allowed. Claim(s) 1-15 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/or	wn from consideration.		
Applicati	on Papers			
10)⊠	The specification is objected to by the Examine The drawing(s) filed on <u>06 August 2003</u> is/are: Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Ex	a)⊠ accepted or b)☐ objected the displayment of accepted or b)☐ objected the drawing(s) is objected if the drawing(s) is objected in the drawing(s) in the drawing(s) is objected in the drawing(s).	e 37 CFR 1.85(a). jected to. See 37 CFR	, ,
Priority u	nder 35 U.S.C. § 119			
a)[Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priority application from the International Bureausee the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National Sta	age
2) 🔲 Notice 3) 🔯 Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	ate	(2)

Application/Control Number: 10/604,636

Art Unit: 2878

DETAILED ACTION

This Office Action is in response to the Applicant's application filed on August 06, 2003.

Applicant's arguments with respect to claims 1-15 have been considered but are most in view of the new ground(s) of rejection.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

Claims 1-4 are rejected under 35 U.S.C. 102(e) as being anticipated by Engelhardt et al (6,958,858).

As to claim 1, Engelhardt et al disclose light sources for the illumination of microscopic specimens (27) comprising a first laser (1) and a second laser (3) wherein

Application/Control Number: 10/604,636 Page 3

Art Unit: 2878

each emits light (5, 7) into a first beam path and into a second beam path; an optical combining means (9) being introduced in the first and in the second beam path; and a displaceable deflection unit (17) for setting a path length difference between the light (5) of the first laser (1) and the light (7) of the second laser (3), (see column 1, lines 18-55, figure 1, column 4, lines 55-67).

As to claim 2, Engelhardt et al disclose the first laser (1) and the second laser (3) are short-pulse lasers that are passively synchronized with one another, (see figure 1, column 4, lines 15-18 and lines 55-67).

As to claim 3, Engelhardt et al disclose a measurement unit (31) for ascertaining cross-correlation is provided, which receives a portion of the light (5) of the first laser (1) and a portion of the light (7) of the second laser (3), and is used to ascertain a setting signal for adjusting the synchronization or controlled delay of the laser pulses of the first laser (1) and/or the second laser (3), (see figure 1, column 4, lines 55-67, column 5, lines 1-5).

As to claims 4, Engelhardt et al disclose the first laser is a Ti:sapphire laser, (see figure 2, column 5, lines 50-53).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Application/Control Number: 10/604,636

Art Unit: 2878

Claims 5-11 and 13-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Engelhardt et al in view of Simon et al (6,356,088) and (6,466,040).

As to claims 5 and 13, Engelhardt et al disclose a second laser (3). Engelhardt et al fail to explicitly teach the second laser is a Nd:YVO4 laser type. Simon et al disclose different lasers such as Nd:YAG laser. It would have been obvious for one ordinary skill in the art to modify Engelhardt et al to include a different laser such as Nd:YAG as disclosed by Simon et al to distinguish the light beams intensity strength and wavelength difference along the optical beam path, (see figure 4, column 5, lines 58-64).

As to claims 6 and 14, Engelhardt et al disclose the first laser (1), the second laser (3), the displaceable deflection unit (17), the optical combining means (9, 21, 23, 25), and the measurement unit (31) for ascertaining cross-correlation of the first laser beam (5) and the second laser beam (7). Engelhardt et al fail to disclose the diode laser and scan module. Simon et al disclose a monitor diode laser and a scan module. It would have been obvious for one ordinary skill in the art to modify Engelhardt et al to include a monitor diode laser located inside a scan module wherein the scan module has been engineered in a highly compact form as disclosed by Simon et al to improve the short pulse laser intensities which allow reflected distinguished wavelength signals from the specimen to be detected and converted into an electrical signal allowing a clear and precise image to be displayed on the monitor in order to perform further critical analysis of the specimen, (see column 1, lines 64-67, figure 2, column 5, lines 35-37).

Application/Control Number: 10/604,636

Art Unit: 2878

As to claim 7, the modified Engelhardt et al disclose the module is flangemounted onto an optical examination apparatus for microscopic specimens, (see column 2, lines 15-18).

As to claim 8, Engelhardt et al discloses a beam deflection device (17) for guiding an illuminated light beam, a microscope optical system (25) for focusing the beam of light, a detector (31) for converting the reflected beam of light, light sources (1, 3) which emits a combined light beam (11) generated by a first laser (1) and a second laser (3), optical combining means (9, 21, 25) for the synchronization of light (5) from the first laser (1) and light (7) from the second laser (3). Engelhardt et al fail to explicitly teach a displaceable deflection unit. Simon et al disclose a two dimensional deflection unit. It would have been obvious for one ordinary skill in the art to modify Engelhardt et al to include a two dimensional deflection unit as disclosed by Simon et al to distinguish the light beams intensity strength and wavelength difference along the optical beam path, (see figure 3, column 3, lines 45-50).

As to claim 9, the modified Engelhardt et al disclose the first laser (1) with a first beam path (5) and the second laser (3) with a second beam path (7), and the optical combiners (9, 21, 25) for the combining of the first beam (5) and the second beam (7), (see figure 1, column 4, lines 55-67).

As to claim 10, the modified Engelhardt et al disclose beam path (5) of the first laser (1) and beam path (7) of the second laser (3). The modified Engelhardt et al fail to disclose a displaceable deflection unit. Simon et al disclose a two dimensional deflection unit (6). It would have been obvious for one ordinary skill in the art to modify

Engelhardt et al to include a two dimensional deflection unit as disclosed by Simon et al to distinguish the light beams intensity strength and wavelength difference along the optical beam path, (see figure 3, column 3, lines 45-50).

As to claim 11, the modified Engelhardt et al disclose the light sources (1, 3) are equipped with a measurement unit (31) for ascertaining cross-correlation which receives a portion of the light (5) of the first laser (1) and a portion of the light (7) of the second laser (3), and can be used to ascertain a setting signal for adjusting the synchronization or controlled delay of the laser pulses of the first laser (1) and/or the second laser (3), (see figure 1, column 4, lines 55-67).

As to claims 12, Engelhardt et al disclose the first laser is a Ti:sapphire laser, (see figure 2, column 5, lines 50-53).

As to claim 15, the modified Engelhardt et al disclose a computer (43) with a display (47) connected to the scan module wherein adjustment data and adjustment aids for synchronization of the first and second laser are displayed for the user, (see figure 1, column 5, lines 29-49).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Don Williams whose telephone number is 571-272-8538. The examiner can normally be reached on 8:30a.m. to 5:30a.m..

Application/Control Number: 10/604,636 Page 7

Art Unit: 2878

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Georgia Epps can be reached on 571-272-2328. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Stephone B. Allen
Primary Examiner